0 3 2003 FORM PTO-1083 **PATENT** RECEIVED SEP 0 5 2003 TO 170 T&A-109 Case Docket No. T. HATTORI et al RE application of Serial No.: 10/026,973 Group Art Unit: 1756 Filed: December 27, 2001 Examiner: S. Rosasco For: A PHOTOMASK, THE MANUFACTURING METHOD, A PATTERNING METHOD AND A SEMICONDUCTOR DEVICE MANUFACTURING METHOD Assistant Commissioner for Patents Washington, D.C. 20231 Sir: Transmitted herewith is an Amendment in the above-identified application. Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted. A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed. No additional fee is required. The fee has been calculated as shown below: OTHER THAN A SMALL ENTITY (COL. 1) (COL. 2) (COL. 3) SMALL ENTITY Highest No. Claims Remaining After Amendment Present Extra Rate Additional OR Rate reviously Paid For 14 20 0 18 1 0 0 Minus 42 \$ 84 First Presentation of Multiple Dependent Claims 140 0 280 OR If the entry in Col. 1 is less than the entry in Col. 2, write '0' in Col. 3.

If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 20, write '20' in this space.

If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 3, write '3' in this space. The 'Highest Number Previously Paid For' (Total or Independent) is the highest number found from the equivalent box in Col. 1 of a prior Amendment or the number of claims originally filed. Please charge my Deposit Account No. 50-1417 in the amount of \$

A check in the amount of \$ is attached in payment of: The Commissioner is hereby authorized to charge payment of the following fees associated with this car Х or credit any overpayment to Deposit Account No. 50-1417.

х Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

Any patent application processing fees under 37 CFR 1.17.

Х Any Extension of Time fees that are necessary, which are hereby requested if necessary

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Date: September 2, 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

T. HATTORI et al

Serial No. 10/026,973

Group Art Unit: 1756

Filed: December 27, 2001

Examiner: S. Rosasco

For: A PHOTOMASK, THE MANUFACTURING METHOD, A PATTERNING

METHOD, AND A SEMICONDUCTOR DEVICE MANUFACTURING METHOD

REPLY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 2, 2003

Sir:

In reply to the Office Action mailed March 14, 2003, please amend the above-identified application as follows.